

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/735,037	KANG ET AL.
	Examiner	Art Unit
	Steven J. Mottola	2817

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST	2/16/2005	S
EAST	5-18-05	S
NPL-IEEE	5-18-05	S

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
330	295	5-18-55	SJ
	302		
	310		